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Mail Stop Amendment - Commissioner for Patents	USPTO	(571) 273-8300	
Date		Client/Matter Number	
June 22, 2006		211843-00032	
From		Attorney Number	
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Total number of pages, including cover letter: pages
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8 pages

Comments

RE: Patent Application No.: 10/519,699

Filing Date: June 26, 2003

Inventor: Thomas Horsky, et al.

Title: An Ion Implantation Device and a Method of Semiconductor Manufacturing by the Implantation of Boron Hydride Cluster Ions
Confirmation No. 6928

Please file the attached:

Transmittal Form (1 p.)

Fee Transmittal Form (1 p.)

Response to Notice of Non-Compliant Amendment (3 pp.)

Petition for Extension of Time (1 p) in duplicate

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PATENT
Attorney Docket No. 211843-00032

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: 10/519,699
I.A. Filing Date: June 26, 2003
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

In response to the Notice of Non-Compliant Amendment of May 12, 2006, please enter the following.

Amendment to the Specification is reflected on page 2.

Remarks begin on page 3 of this paper.